

U.S. Department of Commerce, Patent and Trademark Office	Serial No.: Unknown
	Filing Date: 12/21/01
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Inventor: Vlad J. Novotny
"Pattern-Transfer Process For Forming Micro-Electro-Mechanical Structures"	Group Art Unit: Unknown
	Examiner Name: Unknown
Express Mail Receipt No. EF055078336US	Attorney Docket No.: AO-001-1D

16971 U.S. PRO  
10/026857

12/21/01

## U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date, If Appropriate
SA	AA	6,301,403 B1	10/09/01	Heanue et al.	385	18	
	AB	6,253,001 B1	06/26/01	Storrs T. Hoen	385	17	
	AC	6,028,689	02/22/00	Michalick et al.	359	224	
	AD	5,872,880	02/16/99	Ronald S. Maynard	385	88	
SA	AE	6,283,601 B1	09/04/01	Hagelin et al.	359	871	

## Foreign Patent Documents

							Translation	
		Document Number	Date	Country	Class	Subclass	Yes	No
	AF							

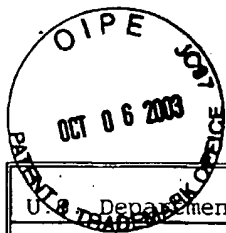
## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

SA	AG	"ROUTING PACKETS WITH LIGHT," Daniel J. Blumenthal. Scientific American, pages 96-99. January 2001.
	AH	"Construction and performance of a 576x576 single-stage OXC," Herzel Laor. LEOS, San Francisco, California, 3 pages. November 8, 1999.
	AI	"Application of micro- and nanotechnologies for the fabrication of optical devices," Wolfgang Ehrfeld and Hans-Dieter Bauer. SPIE Vol. 3276, page 2 and pages 4-14.
	AJ	"PERFORMANCE OF A 576x576 OPTICAL CROSS CONNECT," Laor, et al. NFOEC, Chicago, Illinois, pages 1-5. September 26, 1999.
SA	AK	"Control and shape design of an electrically-damped comb drive for digital switches," Yijian Chen. Proceedings of SPIE Vol. 4178, 2000. Pages 387-394.

Examiner Shamim Ahmed

Date Considered 4/17/04

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.



U.S. Department of Commerce, Patent and Trademark Office	Serial No.: 10/028,657
	Filing Date: 12/21/01
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Inventors: Vlad J. Novotny
"PATTERN-TRANSFER PROCESS FOR FORMING MICRO-ELECTRO-MECHANICAL STRUCTURES"	Group Art Unit: <del>2874</del> 1765
	Examiner Name: Unknown
	Attorney Docket No.: AO-001-1D

## U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date, If Appropriate
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	B	5,783,340	07/21/98	Farino et al.	430	22	
	C	5,462,839	10/31/95	de Rooij et al.	430	320	
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SA	E	5,569,355	10/29/96	Then et al.	156	643.1	

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		Document Number	Date	Country	Class	Subclass	Translation	
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## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

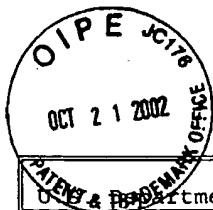
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Examiner *Shamim Ahmed*

Date Considered

*4/17/04*

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Sheet 1 of 1

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Inventor: Vlad J. Novak
"Pattern-Transfer Process for Forming Micro-Electro-Mechanical Structures"	Group Art Unit: 2524
	Examiner Name: Unknown
	Attorney Docket No.: AO-001-1D

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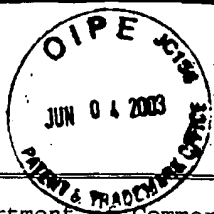
## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

SA	AD	"Silicon micromachines for lightwave networks: the little machines that will make it big," by David Bishop. December 2000. SPIE's Optics & Information Systems. 8 pages.
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	B					
	C					
	D					
	E					

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## Foreign Patent Documents

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
F							

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

SA	G	"Multi-Layer, Self-Aligned Vertical Combedrive Electrostatic Actuators and Fabrication Methods." Inventors: Behrang Behin and Satinderpall Pannu. Publication No.: US 2002/0005976 A1. Publication Date: January 17, 2002. Application No.: 09/810,333, filed March 14, 2001.
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
SA	AD	D.J. Bishop Presentation, "Silicon Micromachines for Lightwave Networks: Can Little Machines Make it Big?" Lucent Technologies, Bell Labs Innovations. 83 pages. February 1999.					
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